



**ELECTRONIC COPY**

LG771650500  
Report verification at igi.org



January 31, 2026

IGI Report Number **LG771650500**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **11.87 X 7.83 X 5.34 MM**

**GRADING RESULTS**

Carat Weight **5.09 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

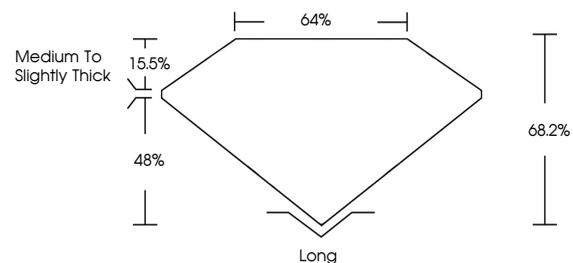
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG771650500**

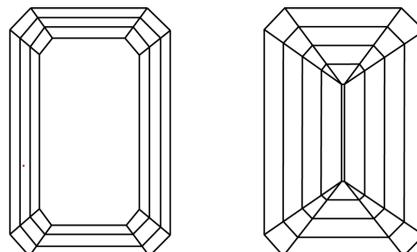
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

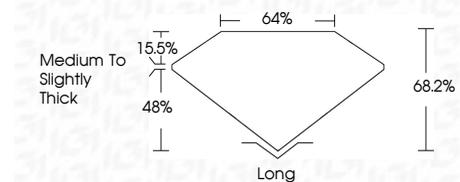
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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EMERALD CUT

5.09 CARATS  
E

11.87 X 7.83 X 5.34 MM

Carat Weight  
Color Grade  
Clarity Grade  
Table  
Girdle  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

5.09 CARATS  
E  
VVS 2  
68.2%  
48%  
Medium to Slightly Thick  
Long  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG771650500

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Type IIa